

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application Of:

Young Yul Kim

Examiner: Anna Crowell

Art Unit: 1763

Appl. No: 10/506,558

Filed: September 1, 2004

For: ELECTRODE FOR DRY ETCHING A
WAFER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR STATUS OF APPLICATION

Dear Examiner Crowell:

Applicant requests a status of the above-identified patent application. Applicant has not received a communication from the U.S. Patent and Trademark Office since submitting a patent application on September 1, 2004.

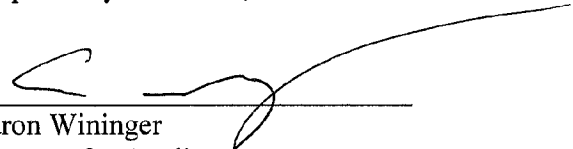
Should the Examiner have any questions regarding this matter, please contact the undersigned at the telephone number shown below.

Date: September 20, 2006

Respectfully submitted,

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By


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